## Search Notes



## Application/Control No.

Applicant(s)/Patent under Reexamination

10/533,462 Examiner MAYERESSE, YVES
Art Unit

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Art Unit 1645

SEARCHED					
Class	Subclass	Date	Examiner		
424	9.1 9.2	9/16/2006	RPS		
435	243 260	9/16/2006	RPS		
435	307.1	9/16/2006	RPS		
updated	above	1/30/2008	RPS		
updated	above	8/3/2008	RPS		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
	DATE	EXMR			
biosis caba caplus embase japio lifesci medline scisearch uspatfull	9/16/2006	RPS			
updated above	1/30/2008	RPS			
updated above	8/3/2008	RPS			